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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO
10/807,670	03/24/2004	Hiromi Nakano	50141-00002	4330
7590 11/08/2004			EXAMINER	
Marsh Fischmann & Breyfogle LLP			NGUYEN, DUNG V	
Suite 411			ART UNIT	PAPER NUMBER
3151 South Vaughn Way Aurora, CO 80014			AKI ONII	FAFER NUMBER
			3723	

DATE MAILED: 11/08/2004

Please find below and/or attached an Office communication concerning this application or proceeding.

		$\mathcal{A}$				
	Application No.	Applicant(s)	<del>                                     </del>			
	10/807,670	NAKANO ET AL.				
Office Action Summary	Examiner	Art Unit	-			
	Dung V Nguyen	3723				
The MAILING DATE of this communication ap Period for Reply	ppears on the cover sheet w	th the correspondence address				
A SHORTENED STATUTORY PERIOD FOR REPL THE MAILING DATE OF THIS COMMUNICATION.  - Extensions of time may be available under the provisions of 37 CFR 1. after SIX (6) MONTHS from the mailing date of this communication.  - If the period for reply specified above is less than thirty (30) days, a replication of the period for reply is specified above, the maximum statutory period.  - Failure to reply within the set or extended period for reply will, by stature Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b).  Status	136(a). In no event, however, may a plus within the statutory minimum of third will apply and will expire SIX (6) MON te, cause the application to become Af	reply be timely filed  by (30) days will be considered timely.  ITHS from the mailing date of this communication.  BANDONED (35 U.S.C. § 133).				
1) Responsive to communication(s) filed on 18 (	October 2004.					
<u> </u>	is action is non-final.					
3) Since this application is in condition for allowa	3) Since this application is in condition for allowance except for formal matters, prosecution as to the merits is					
closed in accordance with the practice under	Ex parte Quayle, 1935 C.D.	. 11, 453 O.G. 213.				
Disposition of Claims						
4) ☐ Claim(s) 1-10 is/are pending in the application 4a) Of the above claim(s) 1-4 is/are withdrawn 5) ☐ Claim(s) is/are allowed. 6) ☐ Claim(s) 5-10 is/are rejected. 7) ☐ Claim(s) is/are objected to. 8) ☐ Claim(s) are subject to restriction and/	n from consideration.					
Application Papers	1					
9) The specification is objected to by the Examin 10) The drawing(s) filed on is/are: a) ac Applicant may not request that any objection to the Replacement drawing sheet(s) including the correct 11) The oath or declaration is objected to by the E	cepted or b) objected to e drawing(s) be held in abeyar ction is required if the drawing	nce. See 37 CFR 1.85(a). (s) is objected to. See 37 CFR 1.121(d)				
Priority under 35 U.S.C. § 119						
a) Acknowledgment is made of a claim for foreig a) All b) Some * c) None of:  1. Certified copies of the priority document 2. Certified copies of the priority document 3. Copies of the certified copies of the priority document application from the International Bureat * See the attached detailed Office action for a list	nts have been received. nts have been received in A ority documents have been au (PCT Rule 17.2(a)).	pplication No received in this National Stage				
Attachment(s)  1) Notice of References Cited (PTO-892)  2) Notice of Draftsperson's Patent Drawing Review (PTO-948)  3) Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08)  Paper No(s)/Mail Date 3/24/04	Paper No(	Summary (PTO-413) s)/Mail Date nformal Patent Application (PTO-152) 				

Art Unit: 3723

#### **DETAILED ACTION**

## **Priority**

1. Applicant cannot rely upon the foreign priority papers to overcome this rejection because a translation of said papers has not been made of record in accordance with 37 CFR 1.55. See MPEP § 201.15.

#### Election/Restrictions

2. Applicant's election of Group II, claims 5-10 in the reply filed on 18 October 2004 is acknowledged. Because applicant did not distinctly and specifically point out the supposed errors in the restriction requirement, the election has been treated as an election without traverse (MPEP § 818.03(a)).

# Claim Rejections - 35 USC § 102

3. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

- (e) the invention was described in (1) an application for patent, published under section 122(b), by another filed in the United States before the invention by the applicant for patent or (2) a patent granted on an application for patent by another filed in the United States before the invention by the applicant for patent, except that an international application filed under the treaty defined in section 351(a) shall have the effects for purposes of this subsection of an application filed in the United States only if the international application designated the United States and was published under Article 21(2) of such treaty in the English language.
- 4. Claims 5-10 are rejected under 35 U.S.C. 102(e) as being anticipated by Okuhata et al (USPN 6,749,487). Claims 5-10 are rejected under 35 U.S.C. 102(e) as being anticipated by Okuhata et al (US 2003/0162482). Okuhata et al discloses a method for manufacturing a glass substrate for use in data recording media in which a polishing pad is used comprising contacting the surface of a glass workpiece with the

Application/Control Number: 10/807,670

Art Unit: 3723

polishing pad with a load of 40 gf/cm<sup>2</sup> on the glass workpiece, polishing the glass workpiece over a polishing period of time in units in minute such that the product between the polishing period of time and the load in units of gf/cm<sup>2</sup> is more than 160, a glass substrate for use in data recording media wherein a micro-waviness height is 0.3 nm. Okuhata et al also discloses a method for manufacturing a glass substrate for use in data recording media comprising lapping a glass workpiece by use of hard pad and a polishing agent containing particles in a range of 1.1 to 1.5 μm, polishing the glass workpiece by using a soft pad and a polishing agent containing particles in a range of 0.2 to 1.0 μm, the soft pad contacts the glass workpiece with a load of 40 gf/cm<sup>2</sup> and the product between the load and polishing period of time is more than 160, wherein the lapping includes an amount of grinding of 40 μm, wherein the polishing of the glass workpiece including an amount of grinding of 3 μm (note Fig. 2, col. 10, line 31 to col. 17, line 44).

Page 3

5. The applied reference has a common inventor with the instant application.

Based upon the earlier effective U.S. filing date of the reference, it constitutes prior art under 35 U.S.C. 102(e). This rejection under 35 U.S.C. 102(e) might be overcome either by a showing under 37 CFR 1.132 that any invention disclosed but not claimed in the reference was derived from the inventor of this application and is thus not the invention "by another," or by an appropriate showing under 37 CFR 1.131.

### Conclusion

Application/Control Number: 10/807,670

**Art Unit: 3723** 

6. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure. Benning et al, Matsuno et al and Saito et al are cited to show a

Page 4

method and apparatus for manufacturing glass workpiece.

7. Any inquiry concerning this communication or earlier communications from the

examiner should be directed to Dung V Nguyen whose telephone number is 703-305-

0036. The examiner can normally be reached on M-F, 6:30-3:00.

8. If attempts to reach the examiner by telephone are unsuccessful, the examiner's

supervisor, Joseph J Hail can be reached on 703-308-2687. The fax phone number for

the organization where this application or proceeding is assigned is 703-872-9306.

9. Information regarding the status of an application may be obtained from the

Patent Application Information Retrieval (PAIR) system. Status information for

published applications may be obtained from either Private PAIR or Public PAIR.

Status information for unpublished applications is available through Private PAIR only.

For more information about the PAIR system, see http://pair-direct.uspto.gov. Should

you have questions on access to the Private PAIR system, contact the Electronic

Business Center (EBC) at 866-217-9197 (toll-free).

DVN

November 4, 2004

Jung vom hognign

PRIMARY EXAMINER